

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Motoyuki Tsuihij et al.  
Filed : February 18, 2004

Art Unit : Unknown  
Examiner : Unknown

Title : METHOD OF FABRICATING A SEMICONDUCTOR DEVICE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

Under 35 USC §120, this application relies on the earlier filing date of application serial number 09/931,554, filed on August 16, 2001. All references listed on form PTO-1449 were submitted to and/or cited by the Office in the prior application and, therefore, copies are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 2/18/04

  
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Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10417-092002	Application No.
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))		Applicant Motoyuki Tsuihiji et al.		
		Filing Date February 18, 2004	Group Art Unit	

<b>U.S. Patent Documents</b>							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,299,513	10/2001	Tsuihiji et al.			
	AB	5,772,900	06/1998	Yorita et al.			
	AC	5,755,614	05/1998	Adams et al.			
	AD	5,240,656	08/1993	Scheeres			
	AE	5,102,594	04/1992	Burlet et al.			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

<b>Foreign Patent Documents or Published Foreign Patent Applications</b>							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No
	AL	11-19672	01/26/1999	Japan			
	AM						
	AN						
	AO						
	AP						

<b>Other Documents (include Author, Title, Date, and Place of Publication)</b>		
Examiner Initial	Desig. ID	Document
	AQ	Patent Abstracts of Japan; 11-019672; 26/01/1999
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	